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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber

Art Unit: 2818

Serial No.: 10/714,366

Examiner: Nguyen, T.

Filing Date: 11/13/2003

Docket No.: TI-36280

Customer No.: 23494

Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A
SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH
PROCESSES

CERTIFICATION OF FACSIMILE TRANSMISSION

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NAME OF INVENTOR(S): Wasshuber		RECEIPT DATE & SERIAL NO.: Serial No.: 10/714,366 Filing Date: 11/13/2003 Conf. No.: 1864	
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TI FILE NO.: TI-36280	DEPOSIT ACCT. NO.: 20-0668		
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